

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appln. No: 10/712,087
Applicants: Kazuhisa Yamamoto et al.
Filed: November 13, 2003
Title: OPTICAL DEVICE, LASER BEAM SOURCE, LASER APPARATUS AND METHOD
OF PRODUCING OPTICAL DEVICE
T.C./A.U.: 2828
Examiner: Tod Thomas Van Roy
Confirmation No.: 7923
Docket No.: SNK-3750US3

SUBSTANCE OF INTERVIEW


Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

S I R:

A telephone interview was conducted with the Examiner and his Supervisor on March 12, 2008 regarding the above-identified application.

During the course of the interview, the differences between Yamamoto et al. and proposed claim 78 were described. No agreement was reached.

Respectfully submitted,



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DMG/nm

Dated: March 13, 2008

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